

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **KAWARAYA, Masahide, et al.**

Group Art Unit: **2813**

Serial No.: **10/530,475**

Examiner: **Colleen E. Rodgers**

Filed: **April 6, 2005**

P.T.O. Confirmation No.: 4981

**FOR: PROCESS FOR FORMING SEMICONDUCTOR FILM AND USE OF
SEMICONDUCTOR FILM**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 27, 2007

Sir:

In response to the Office Action dated **February 20, 2007**, extended to **June 27, 2007**, by payment of a **2-month** Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.